



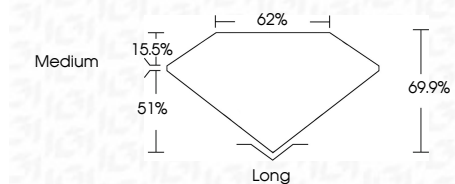
ELECTRONIC COPY

LG640458864
Report verification at igi.org



June 29, 2024
IGI Report Number **LG640458864**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **8.58 X 5.69 X 3.98 MM**

GRADING RESULTS
Carat Weight **1.88 CARAT**
Color Grade **E**
Clarity Grade **VS 2**



ADDITIONAL GRADING INFORMATION
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG640458864**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



June 29, 2024
IGI Report No. **LG640458864**
EMERALD CUT
8.58 X 5.69 X 3.98 MM
1.88 CARAT
E
VS 2
69.9%
51%
62%
Medium
Long
EXCELLENT
EXCELLENT
NONE
IGI LG640458864
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LABORATORY GROWN DIAMOND REPORT

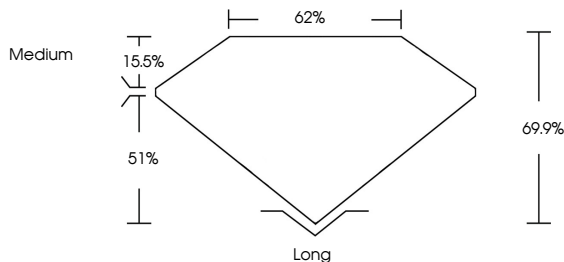
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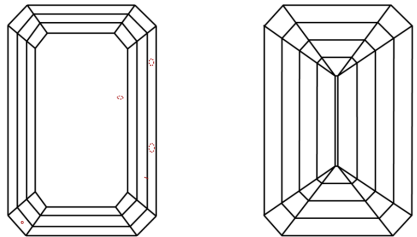
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PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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